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(12) **United States Design Patent**
Riker et al.

(10) **Patent No.: US D858,468 S**
(45) **Date of Patent: ** Sep. 3, 2019**

(54) **COLLIMATOR FOR A PHYSICAL VAPOR DEPOSITION CHAMBER**

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(**) Term: **15 Years**

(21) Appl. No.: **29/640,787**

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(51) **LOC (12) Cl.** **13-03**

(52) **U.S. Cl.**
USPC **D13/182**

(58) **Field of Classification Search**
USPC D13/182; D15/144, 144.1, 138; D7/667; 204/298.11

(Continued)

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(57) **CLAIM**

The ornamental design for a collimator for a physical vapor deposition chamber, as shown and described.

DESCRIPTION

FIG. **1** is a top perspective view of a first embodiment of a collimator for a physical vapor deposition chamber, showing our new design;
FIG. **2** is a bottom perspective view thereof;
FIG. **3** is a top plan view thereof;
FIG. **4** is a bottom plan view thereof;
FIG. **5** is a right side elevation view thereof;
FIG. **6** is a left side elevation view thereof;
FIG. **7** is a front elevation view thereof;
FIG. **8** is a back elevation view thereof;
FIG. **9** is a cross sectional view taken along line **9-9** in FIG. **3**;
FIG. **10** is a cross sectional view taken along line **10-10** in FIG. **3**;
FIG. **11** is a top perspective view of a second embodiment of a collimator for a physical vapor deposition chamber, showing our new design;
FIG. **12** is a bottom perspective view thereof;
FIG. **13** is a top plan view thereof;
FIG. **14** is a bottom plan view thereof;
FIG. **15** is a right side elevation view thereof;
FIG. **16** is a left side elevation view thereof;
FIG. **17** is a front elevation view thereof;
FIG. **18** is a back elevation view thereof;
FIG. **19** is a cross sectional view taken along line **19-19** in FIG. **13**; and,
FIG. **20** is a cross sectional view taken along line **20-20** in FIG. **13**.

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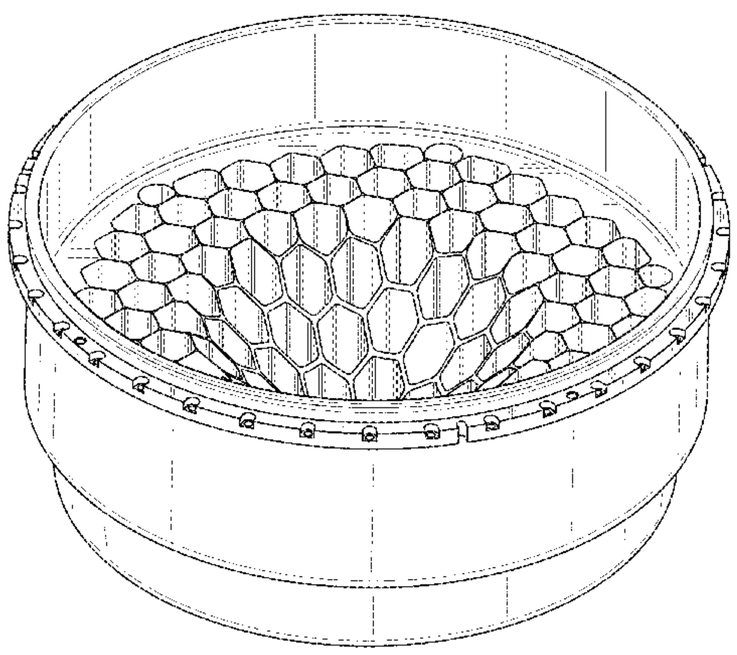

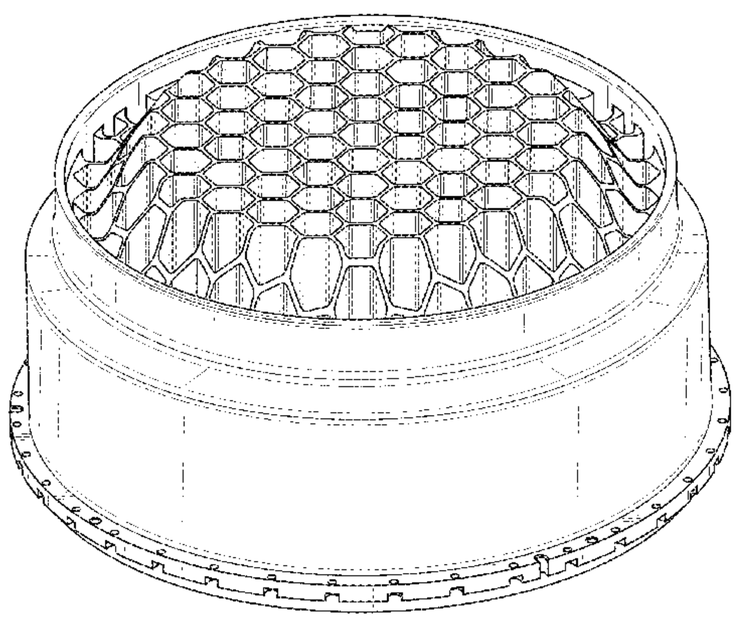

The dashed lines in the drawings represent unclaimed environment and form no part of the claimed design.

1 Claim, 20 Drawing Sheets

(58) **Field of Classification Search**
CPC H01J 37/3441; H01J 37/3447; H01J 37/34; C23C 14/34; C23C 14/04; C23C 14/042; C23C 14/044; C23C 14/046; C23C 14/35; C23C 14/3471; C23C 14/22
See application file for complete search history.

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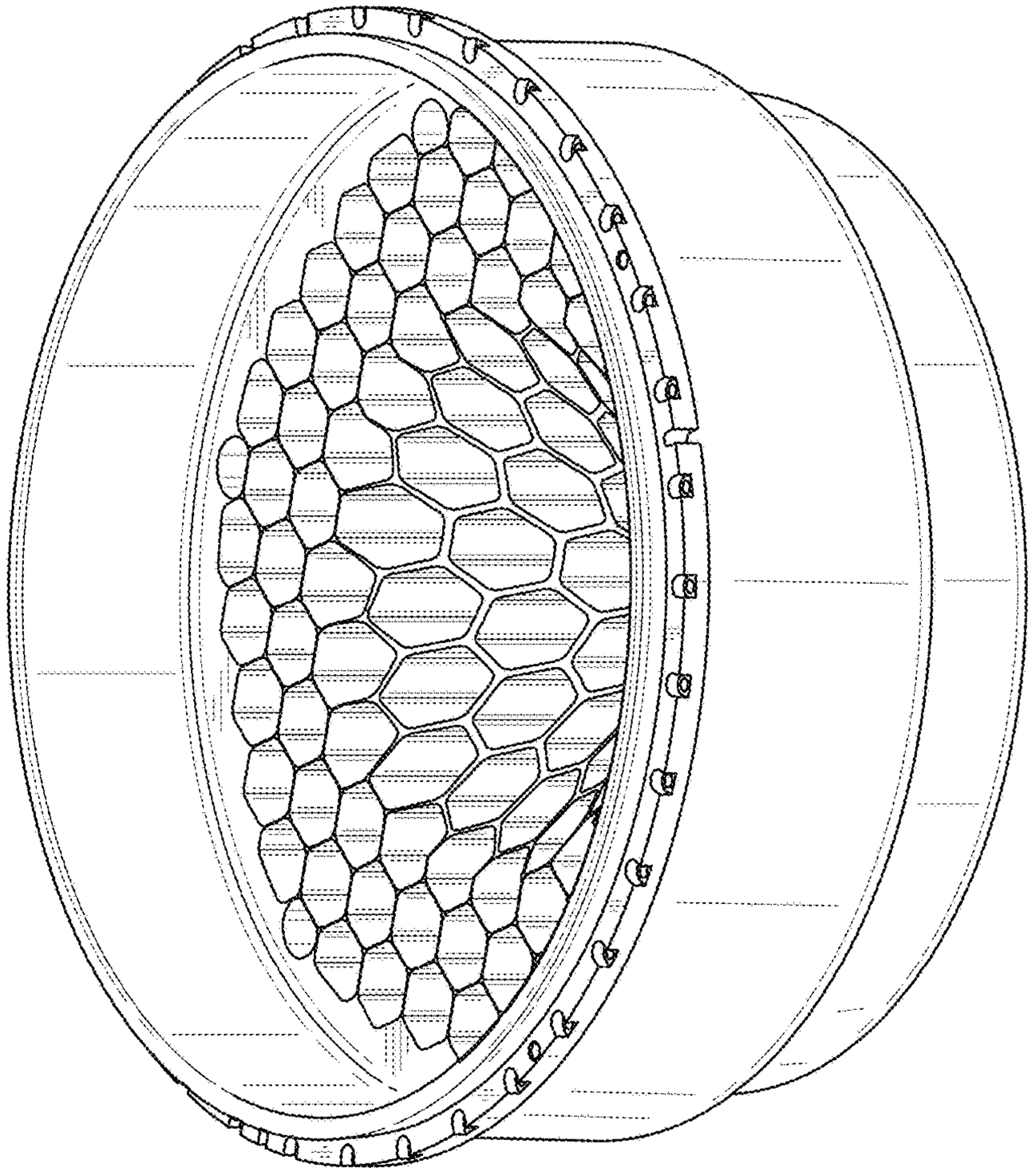


FIG. 1

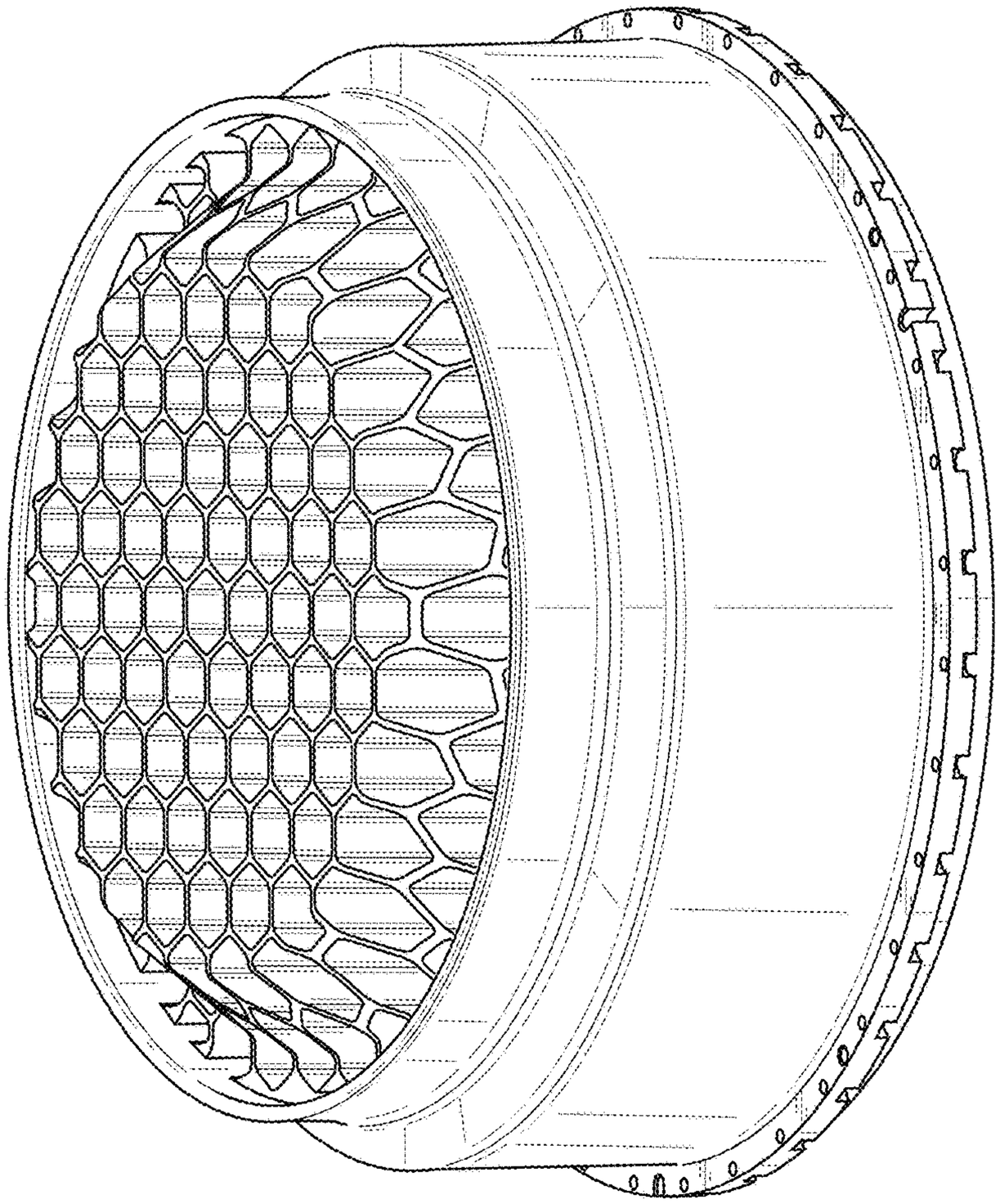


FIG. 2

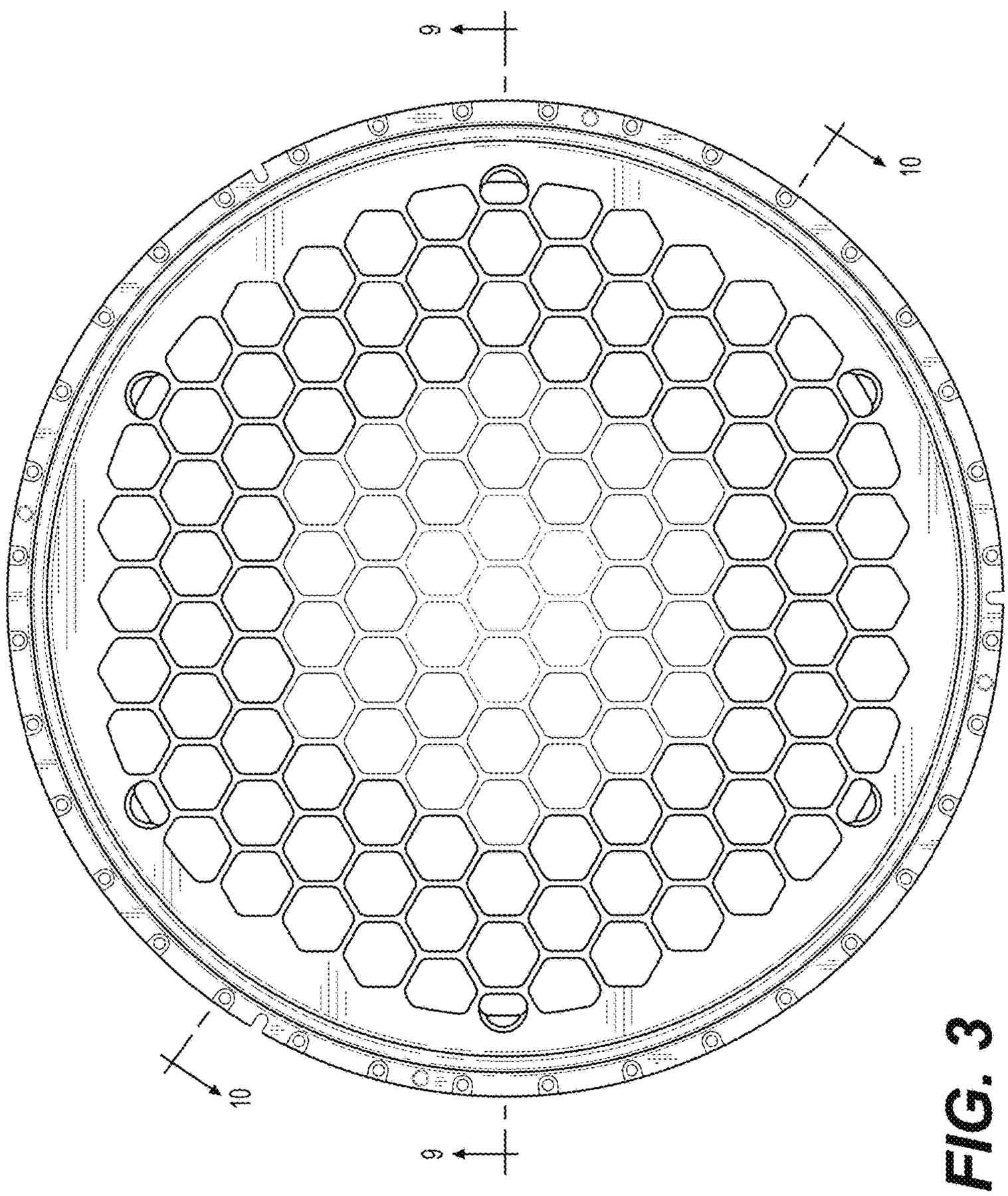
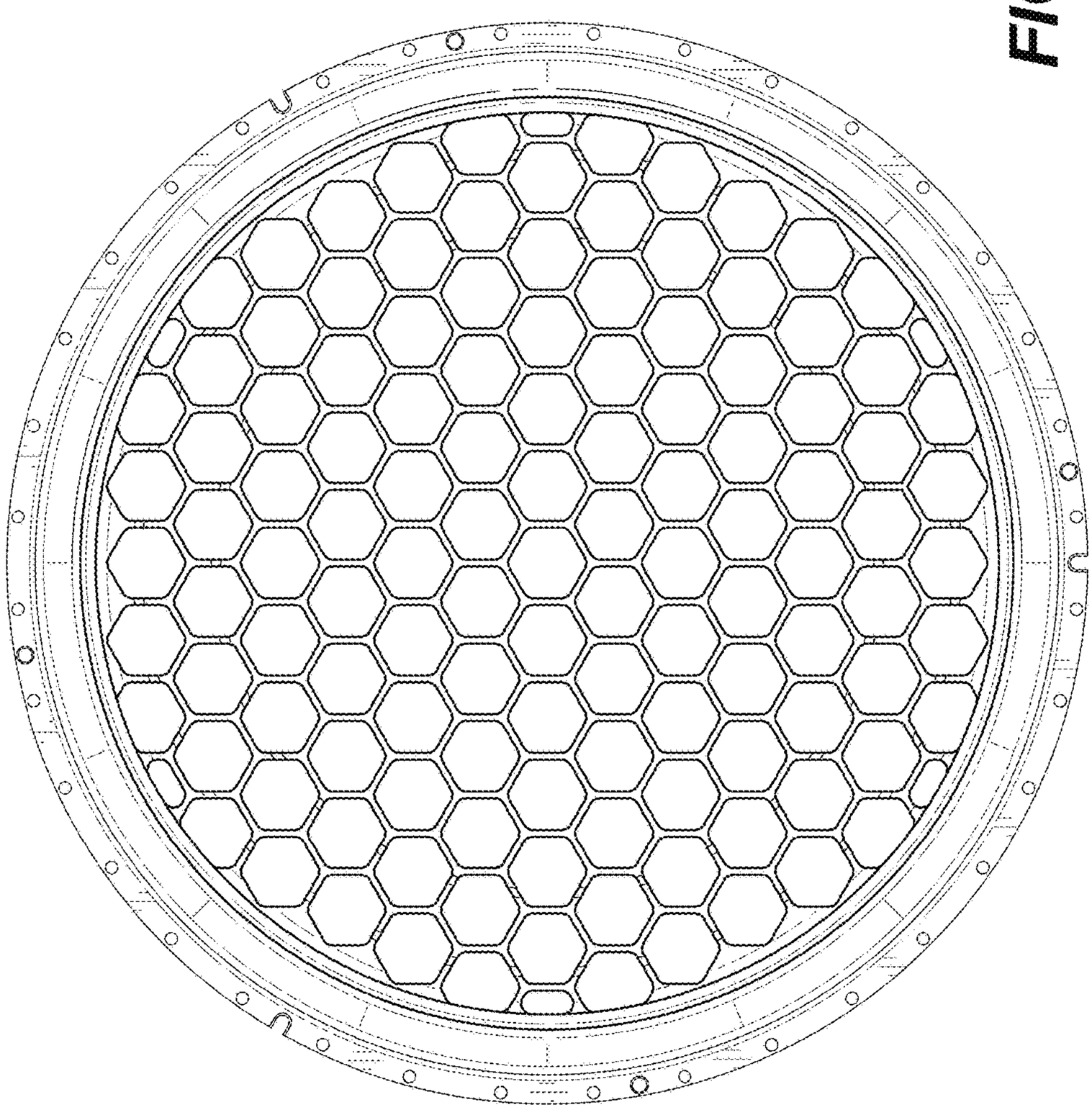


FIG. 3

FIG. 4



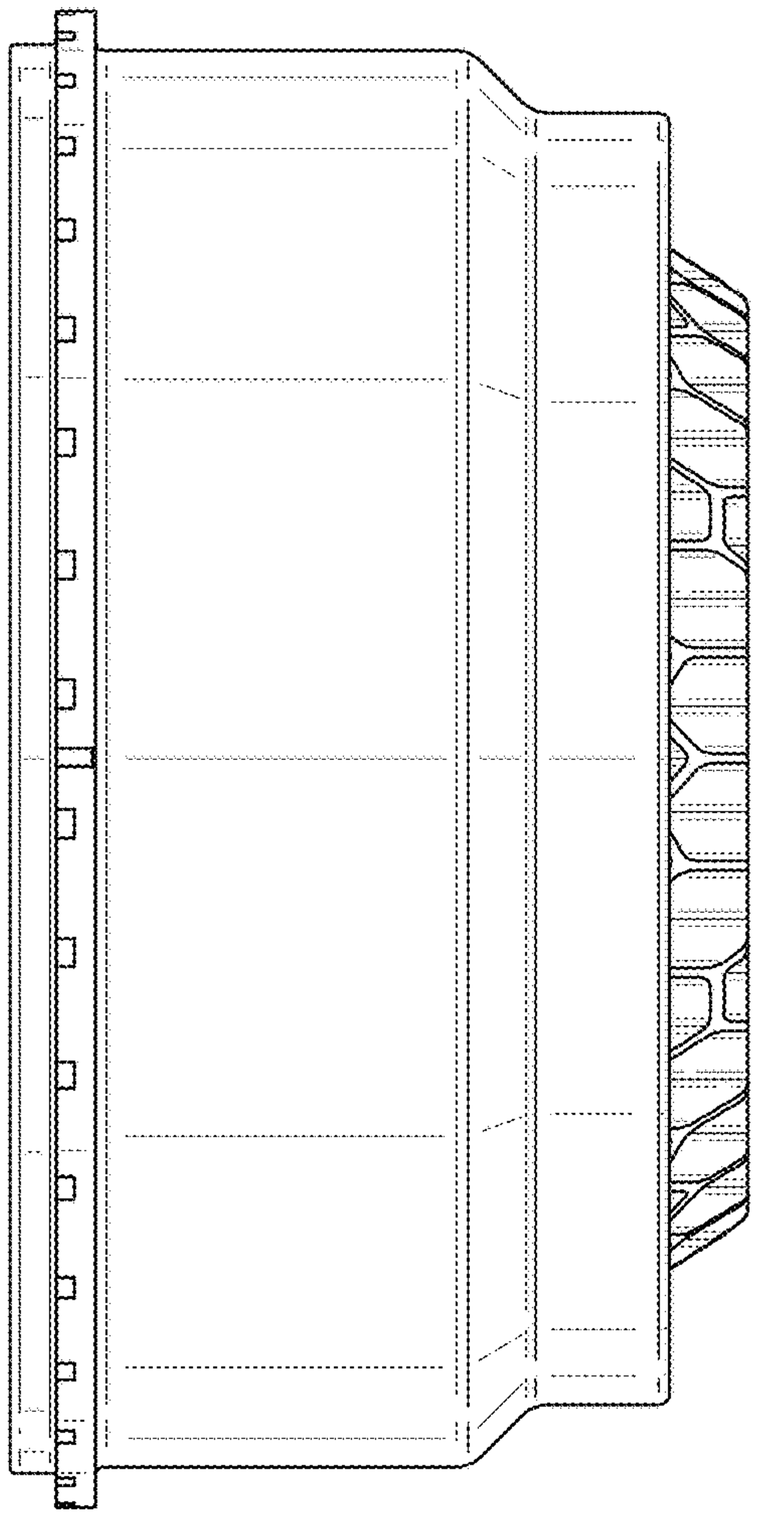


FIG. 5

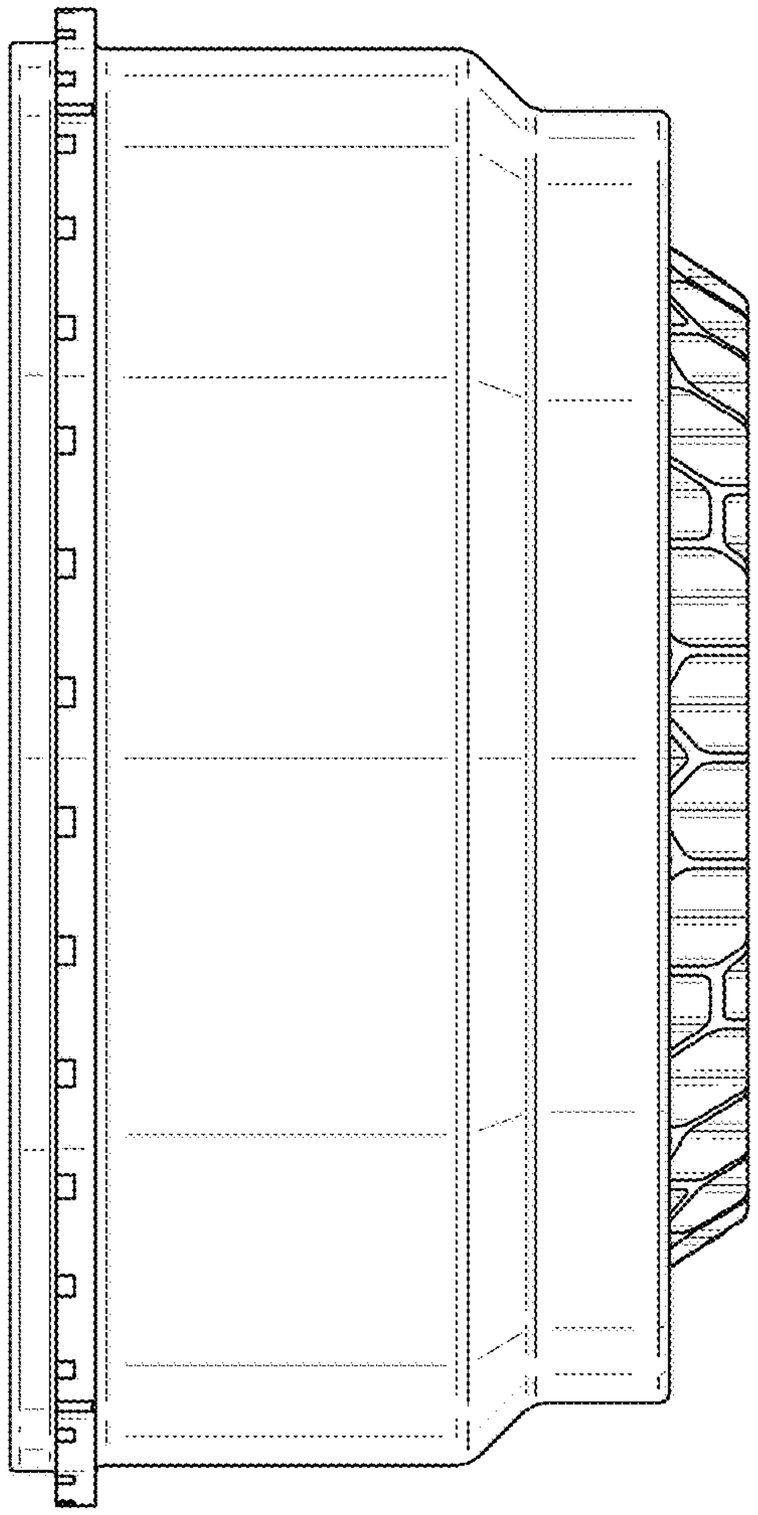


FIG. 6

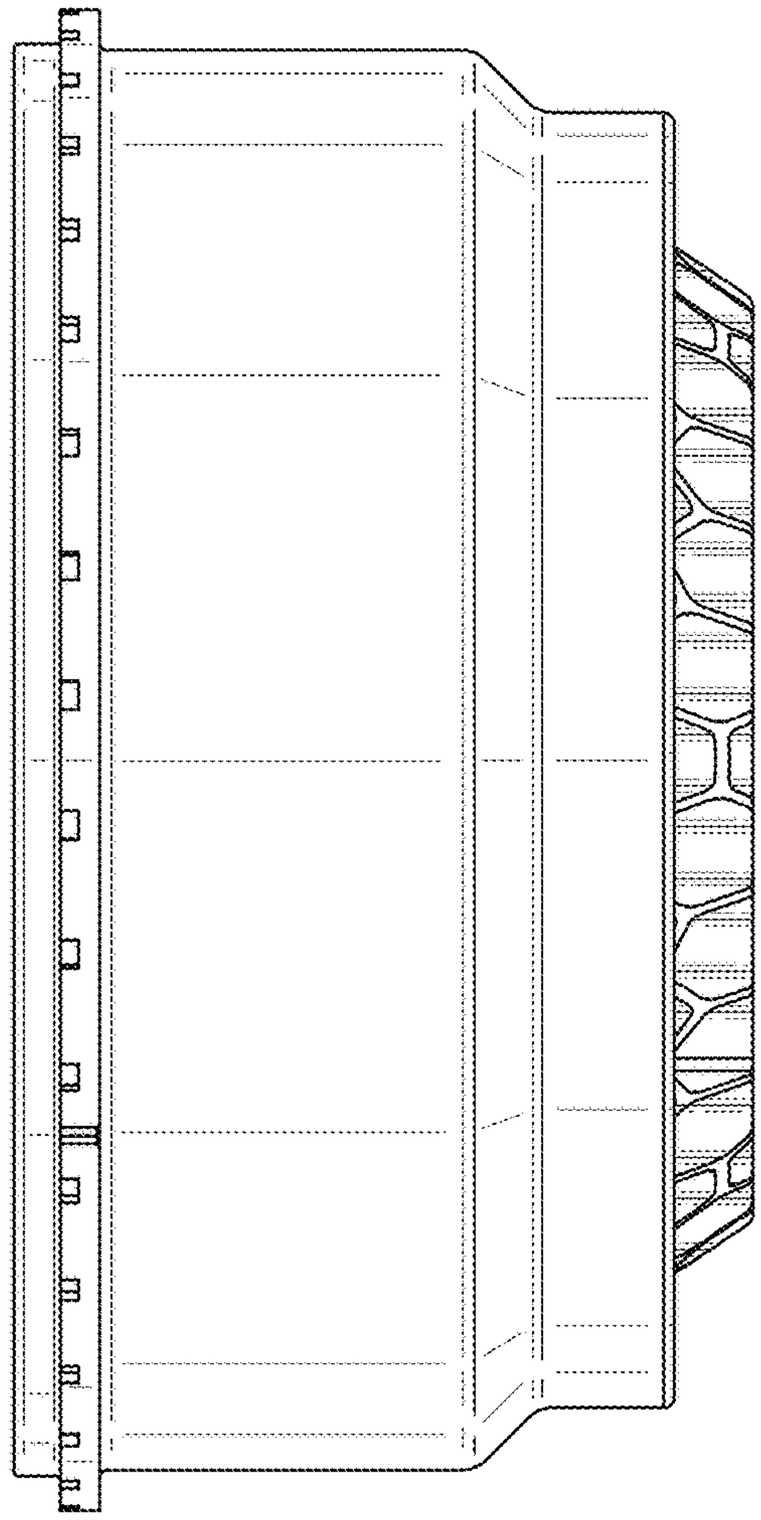


FIG. 7

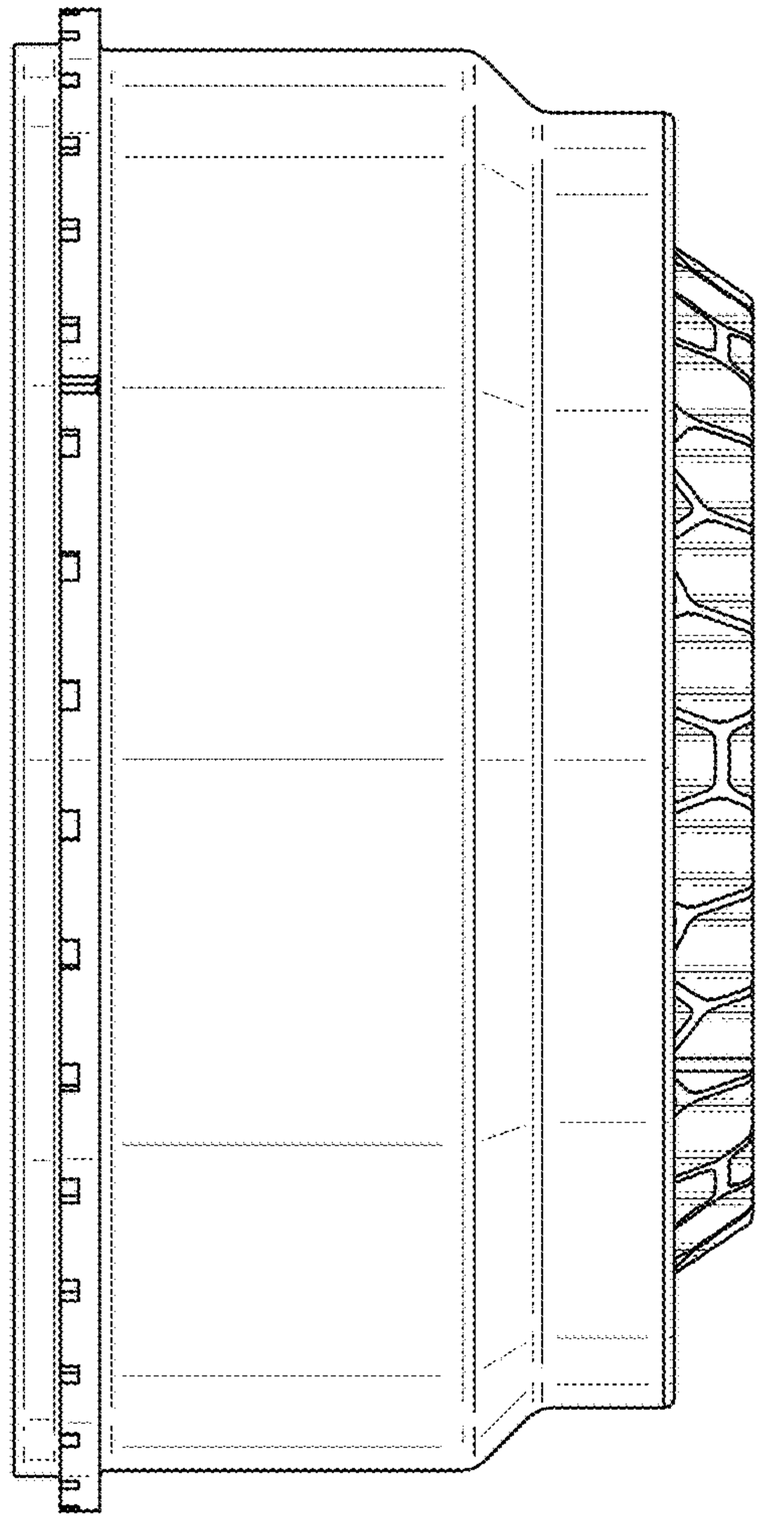


FIG. 8

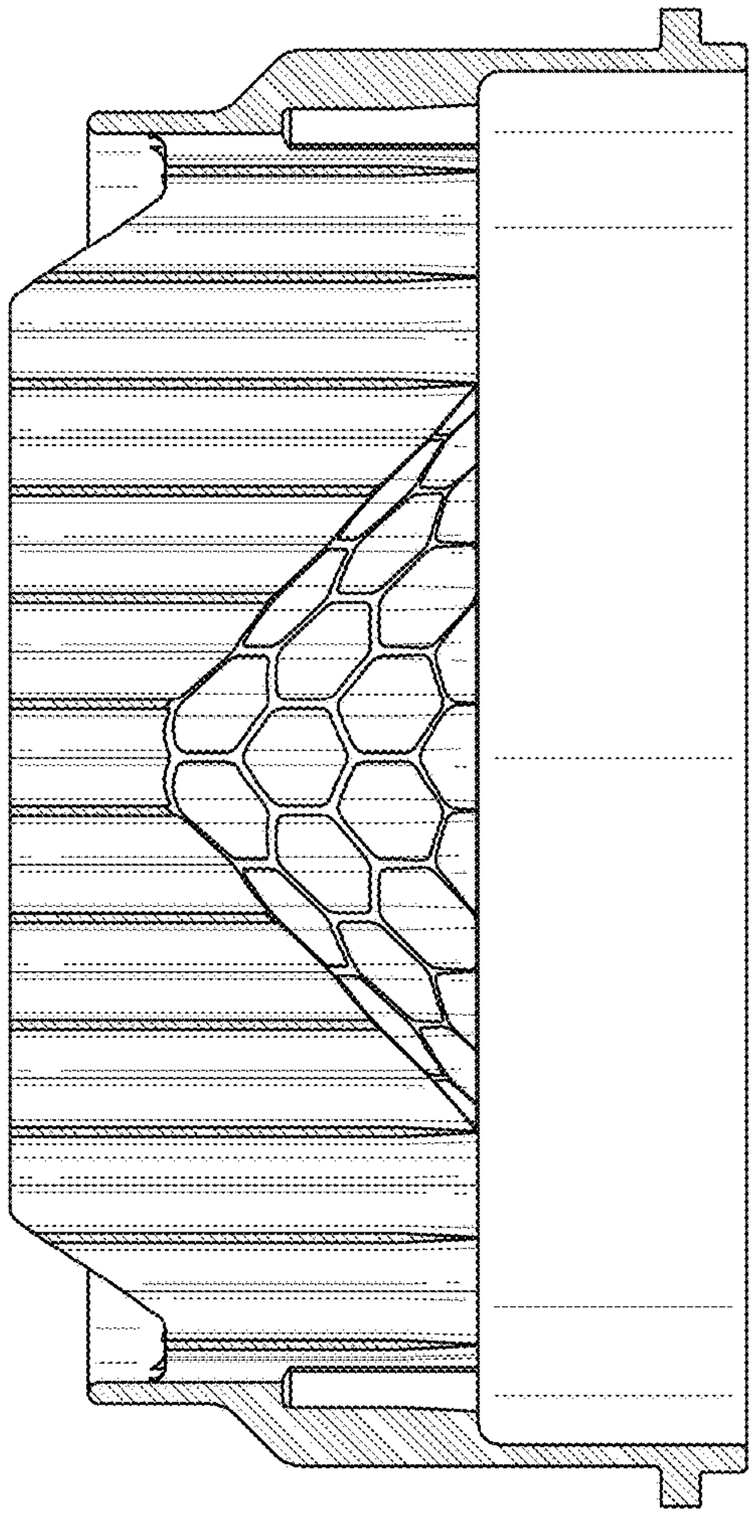


FIG. 9

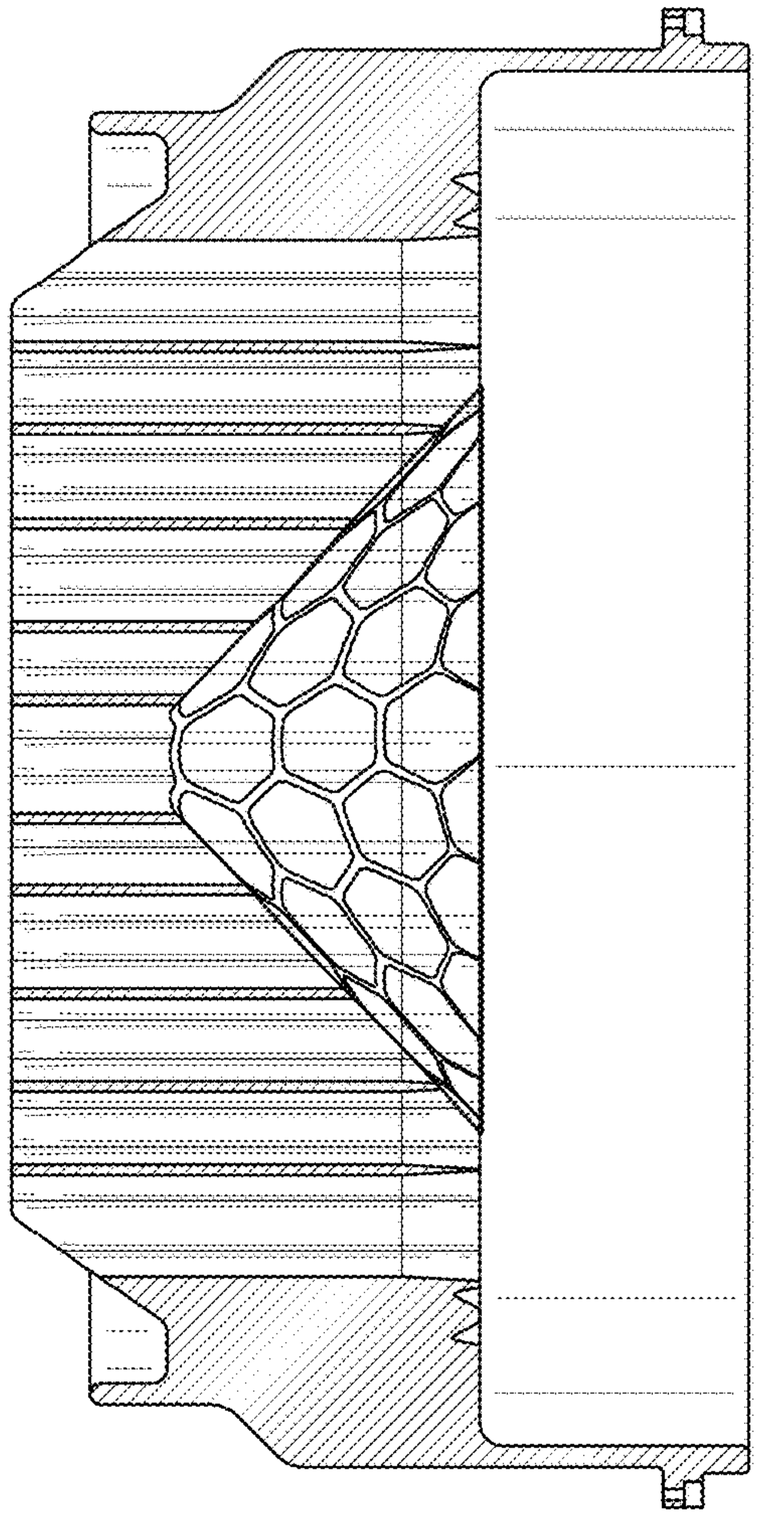


FIG. 10

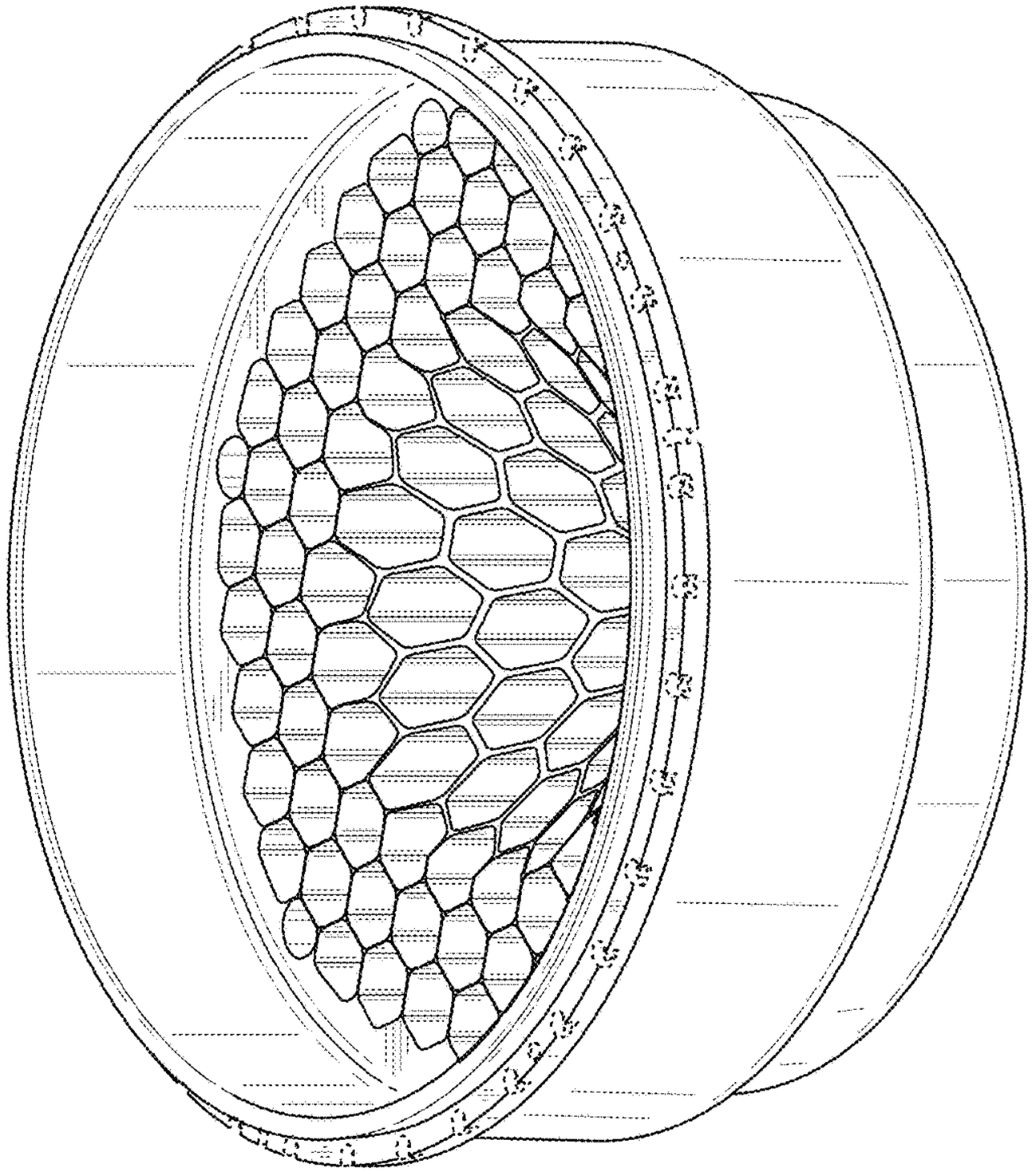


FIG. 11

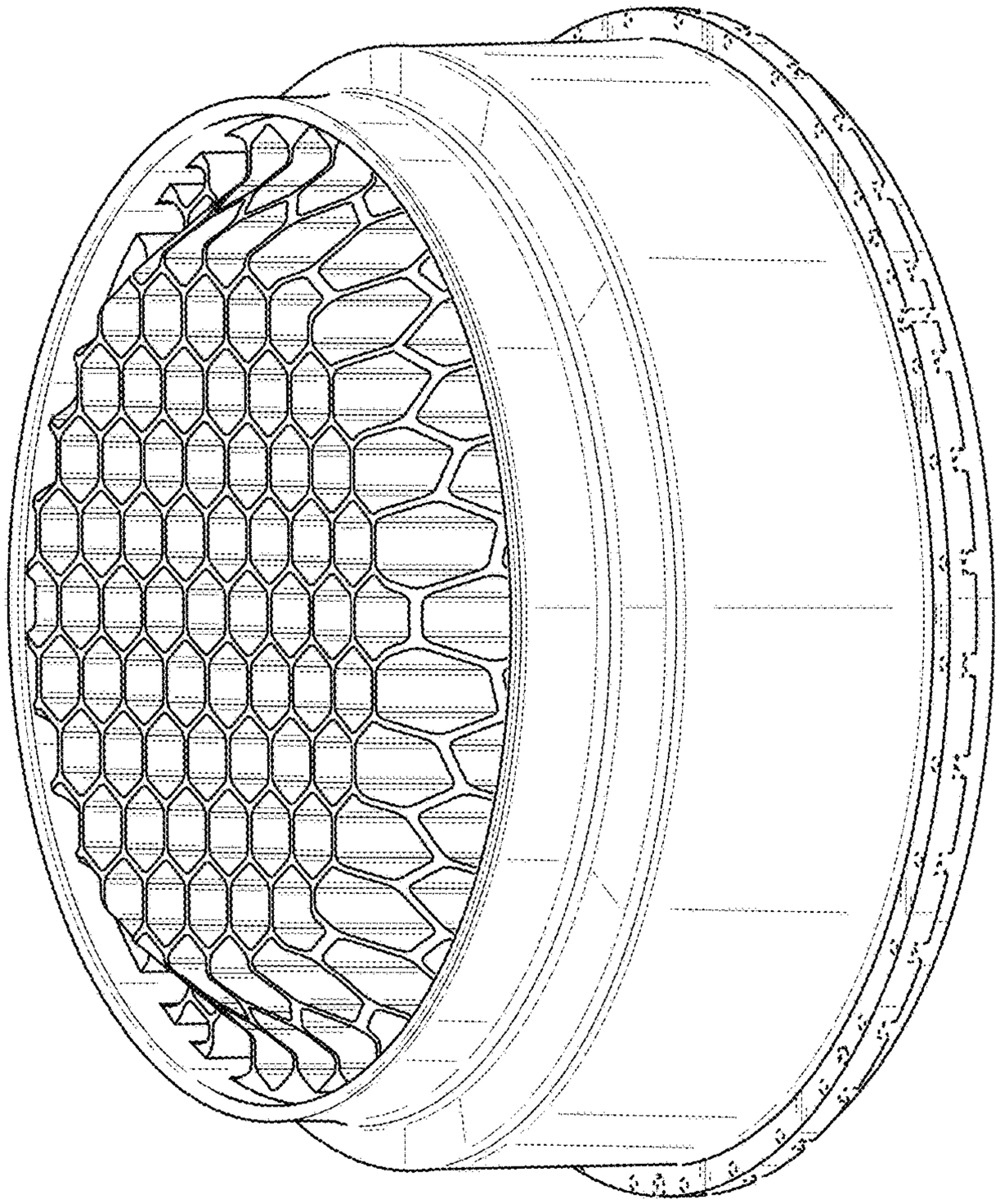


FIG. 12

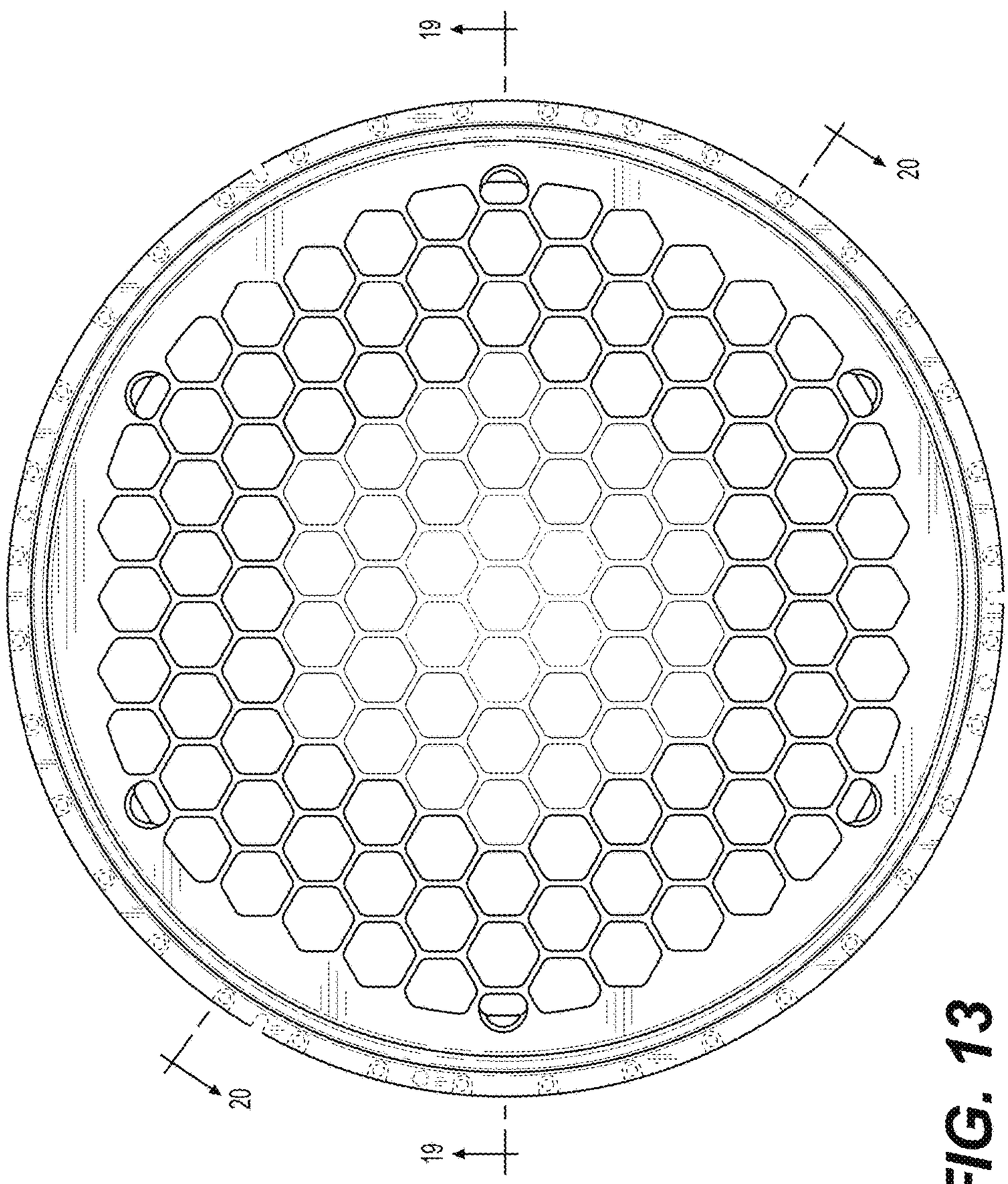
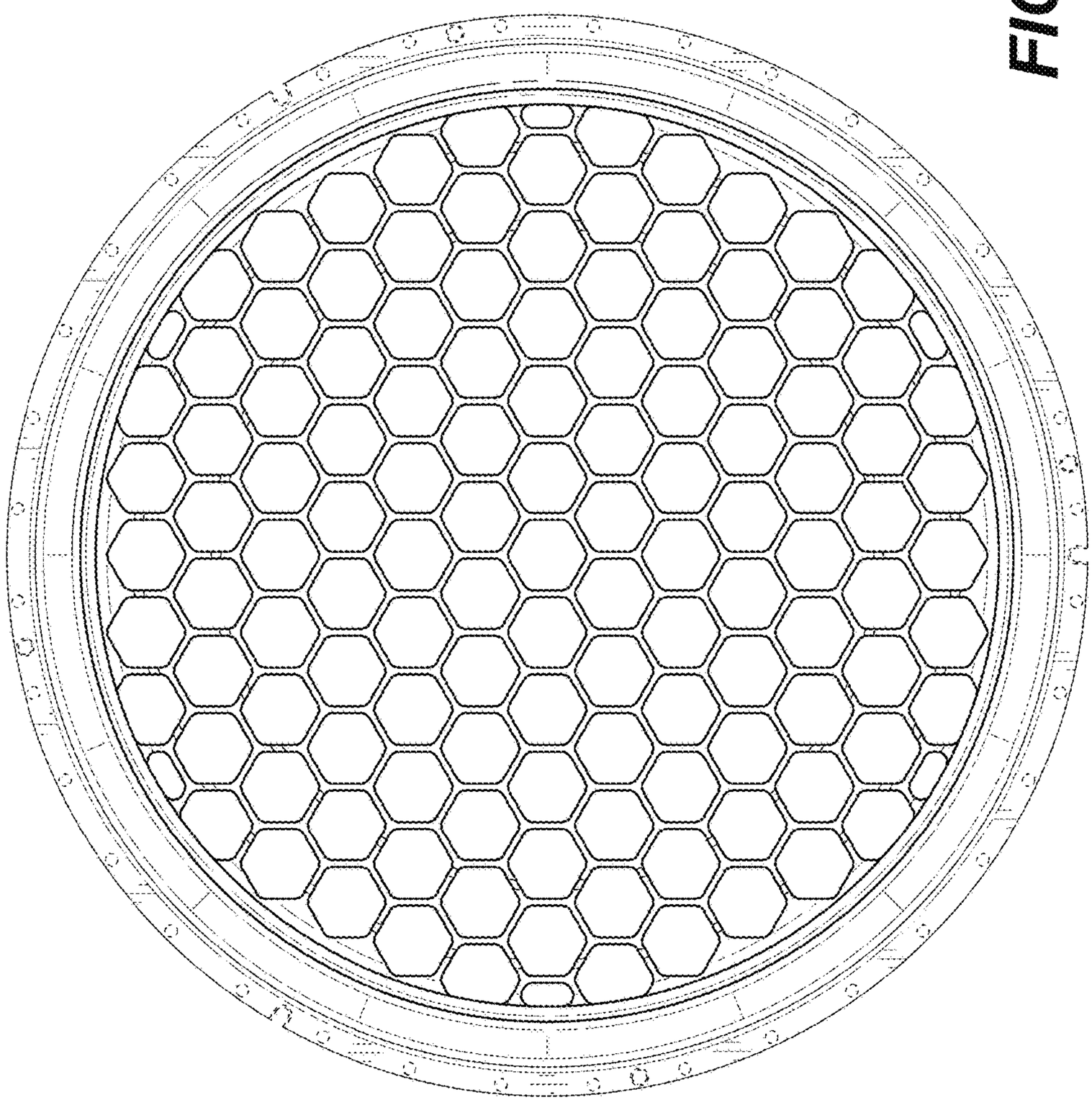


FIG. 13

FIG. 14



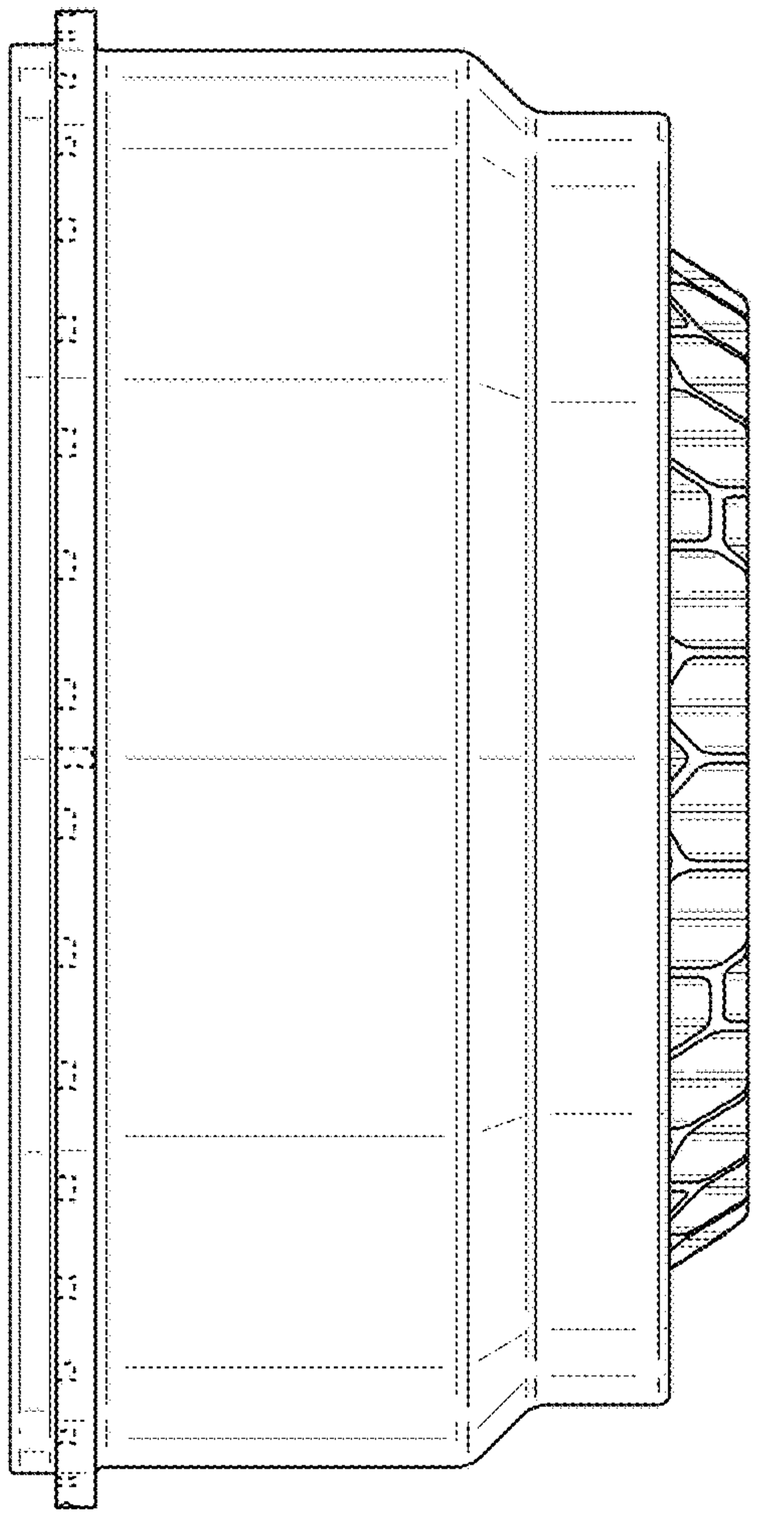


FIG. 15

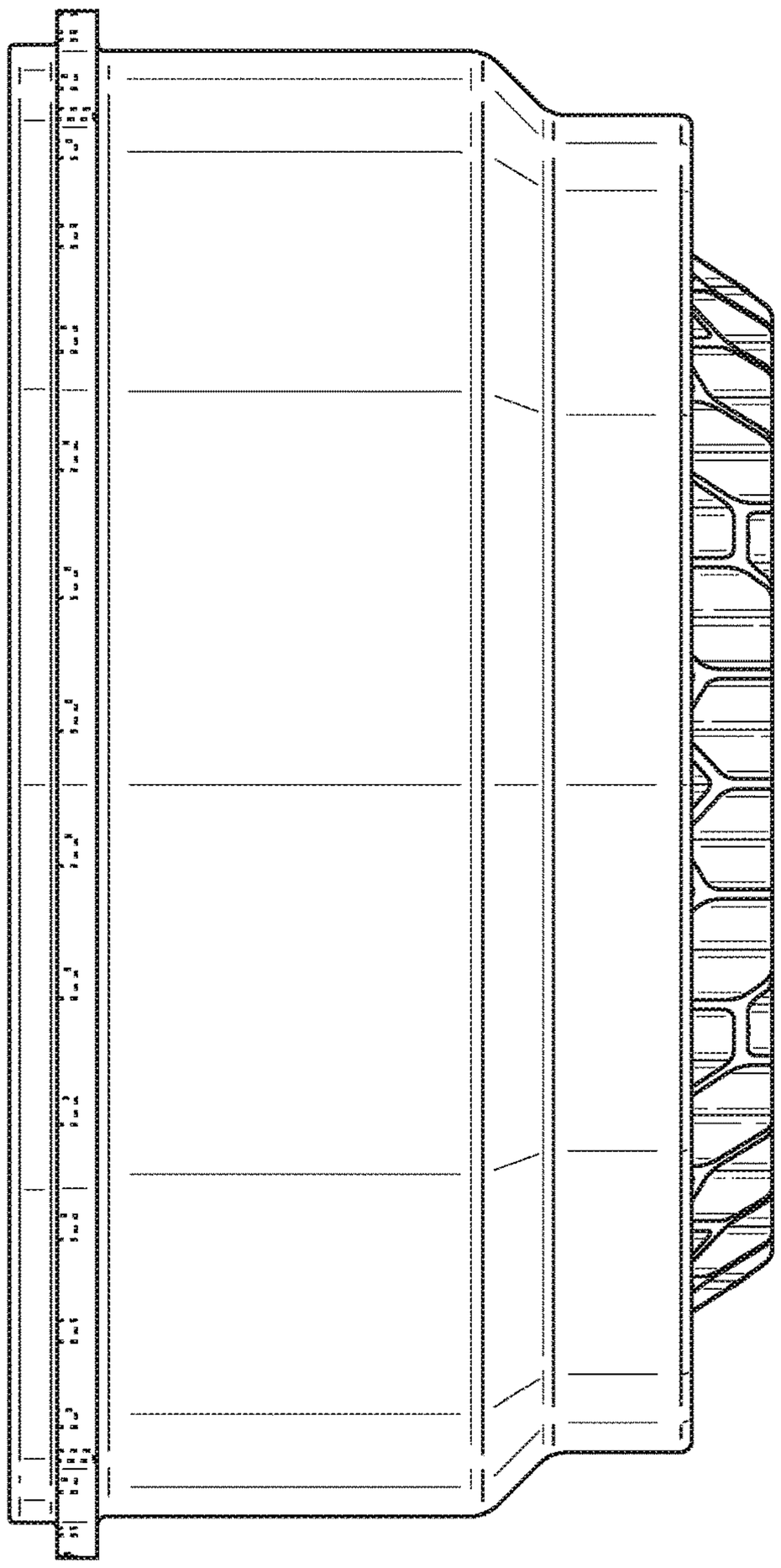


FIG. 16

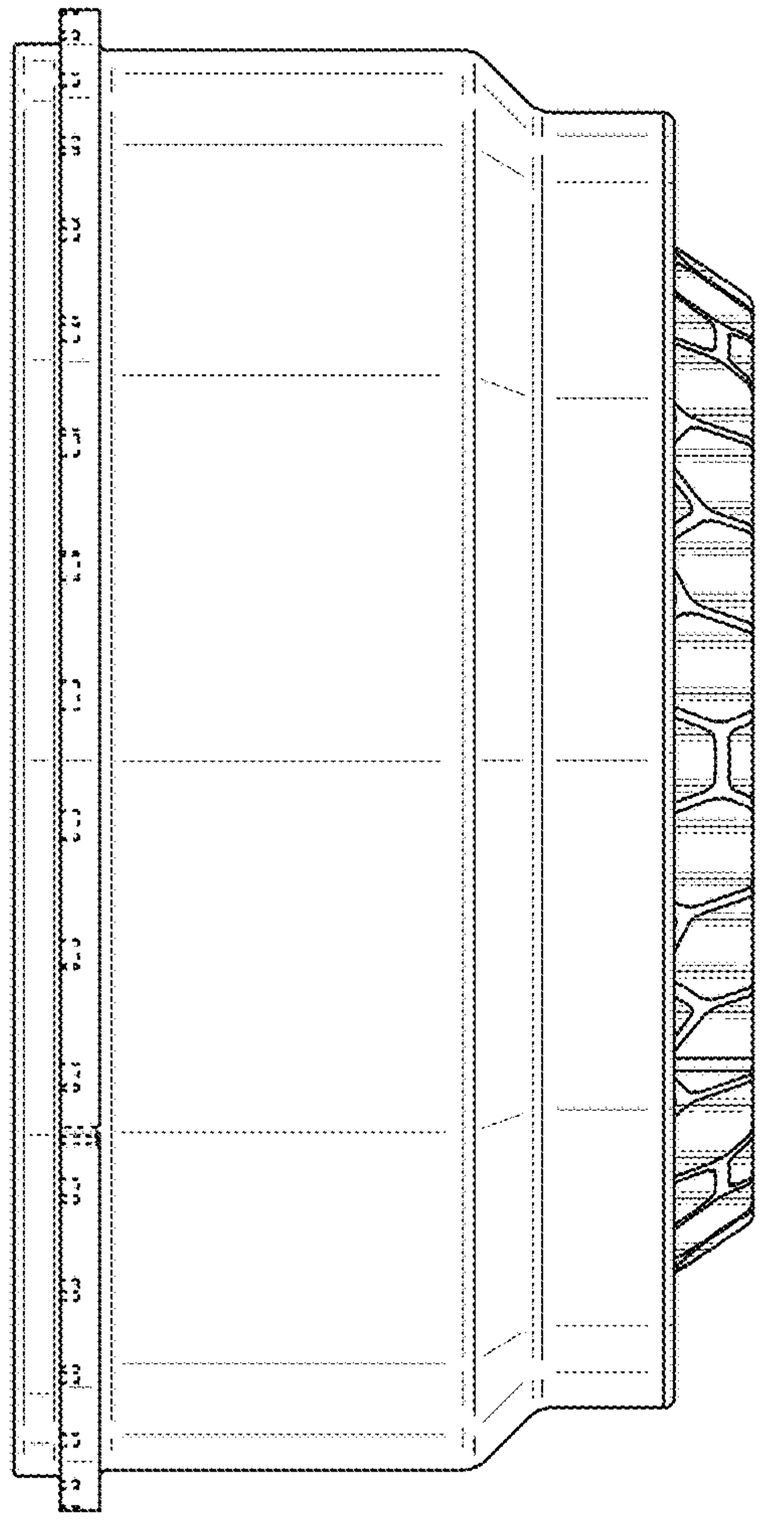


FIG. 17

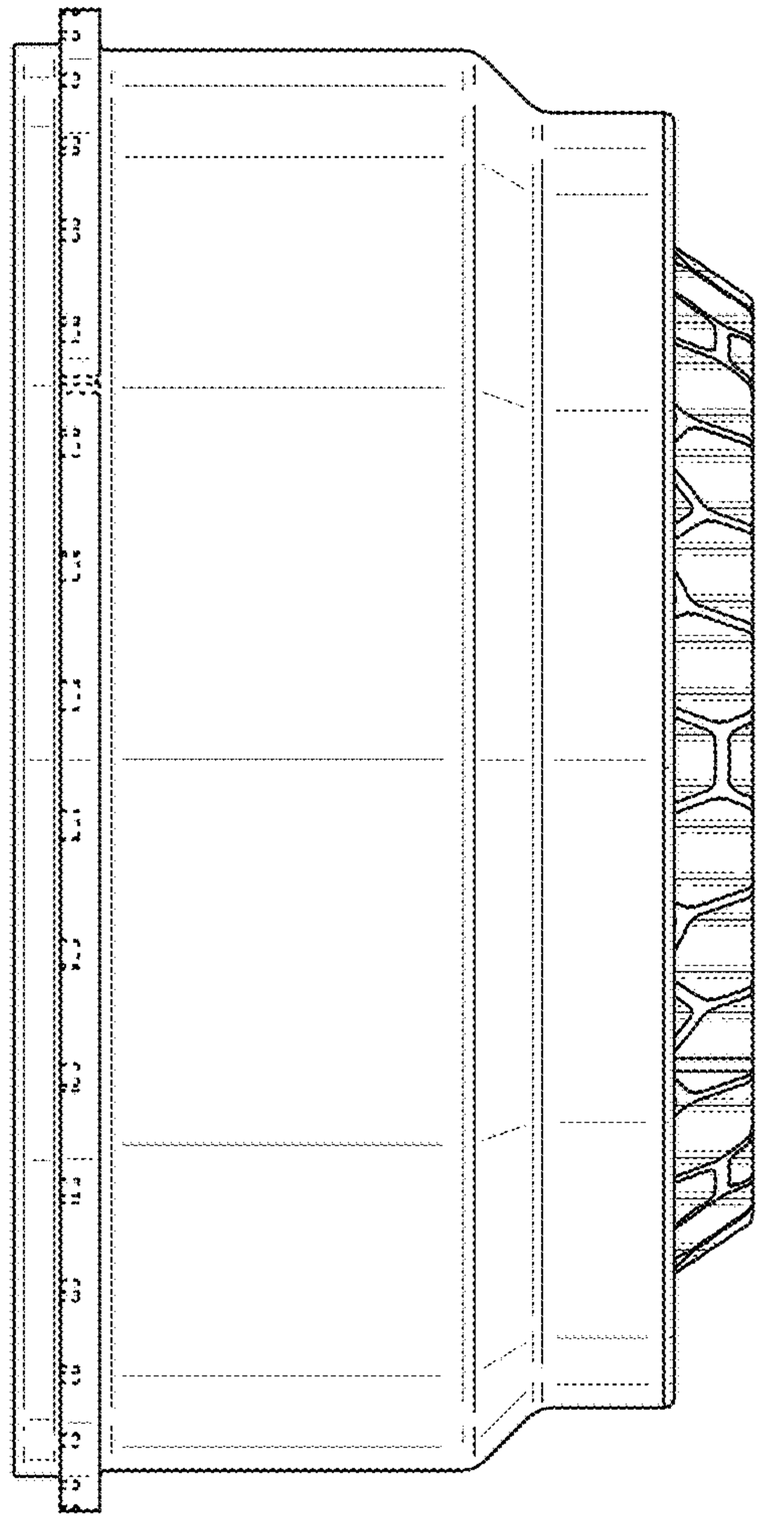


FIG. 18

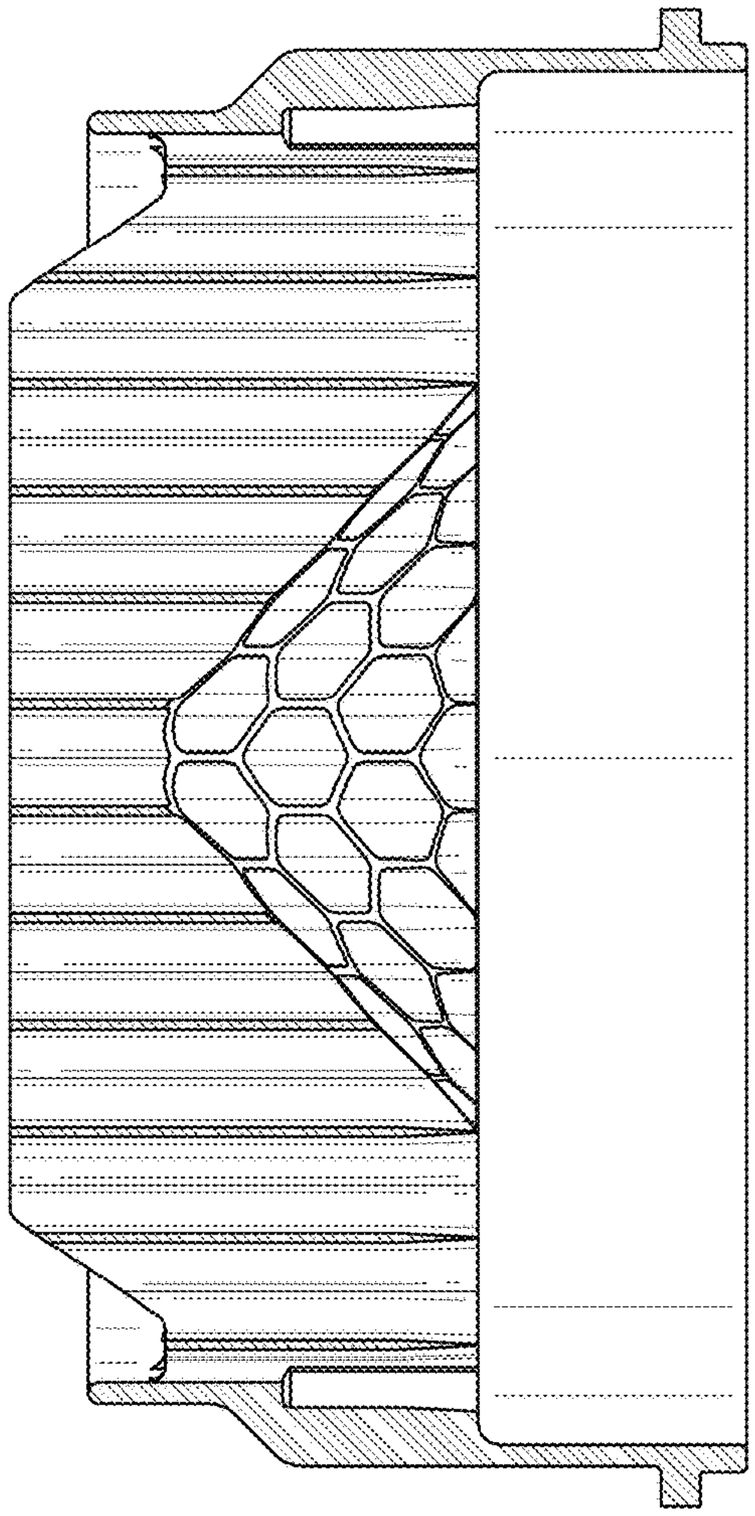


FIG. 19

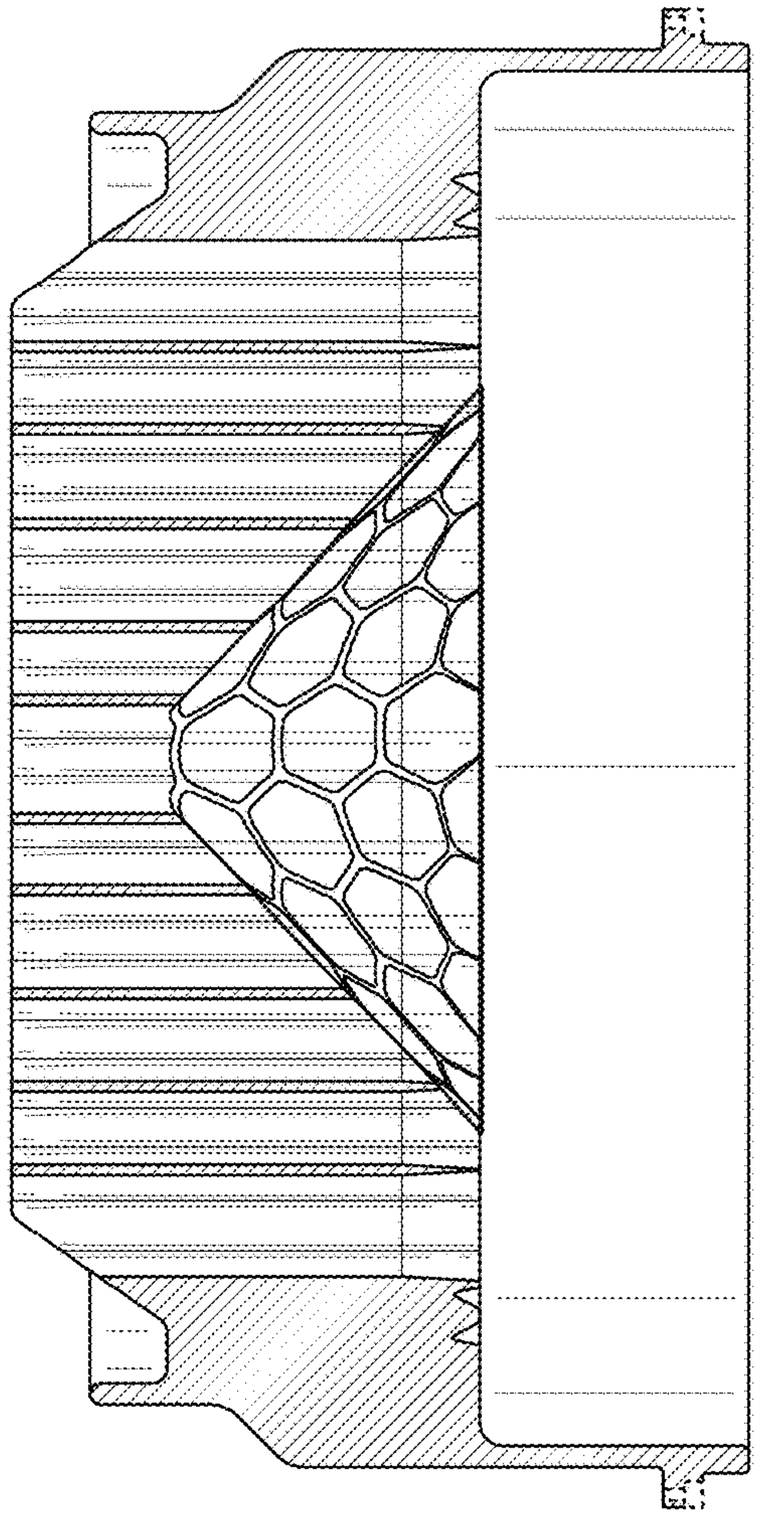


FIG. 20